

AMENDMENTS TO THE SPECIFICATION:

Please amend the paragraph on page 6, starting from line 11 as follows:

FIG. 1 shows a schematic diagram indicating one embodiment of an apparatus that can preferably carry out a method for forming a catalyst layer on a substrate that constitutes an MEA of the present invention.

FIG. 2 shows a schematic diagram indicating another embodiment of the apparatus according to the present invention.

Please amend the paragraph on page 7, line 2 from the bottom to page 8, line 3 as follows:

Further, the apparatus A comprises a voltage applying means 20 that applies a voltage of 0 kV to 10 kV upon the screen 5 so that an electric field is applied between the substrate 2 and the screen 5. If necessary, a means for triboelectrification (not shown), using corona discharge, stirring, or the like is disposed to serve as a means of electrically charging the electrode powder 10 accommodated in the hopper 6.